

SISTEMA	EMEP
NOBREGATURA	ESTACION DE TECNOLOGIA DE SUPERFICIE EMEP 1
MODELO / PN / UNID.	INSTRON
FABRICANTE	AMM Systems
NOBAC	00002/00007/0001

SENSOR / MÓDULO	GRANDEZA	MODELO / PN	FABRICANTE	MODELO / PN ALTERNADO 1	FABRICANTE	MODELO / PN ALTERNADO 2	FABRICANTE	MODELO / PN ALTERNADO 3	FABRICANTE	MODELO / PN ALTERNADO 4	FABRICANTE	MODELO / PN ALTERNADO 5	FABRICANTE	MODELO / PN ALTERNADO 6	FABRICANTE	MODELO / PN ALTERNADO 7	FABRICANTE	MODELO / PN ALTERNADO 8	FABRICANTE	MODELO / PN ALTERNADO 9	FABRICANTE	MODELO / PN ALTERNADO 10	FABRICANTE
REGISTRADOR DE DADOS ("DATA LOGGER") / PROCESSADOR	---	CR1000	CAMPBELL	CR800	CAMPBELL	EVOLUTION	NEEA	AM5111 (I) / (N)	MicroStep-MIS	---	---	---	---	---	---	---	---	---	---	---	---	---	---
SISTEMA DE PROCESSAMENTO E VISUALIZAÇÃO DE DADOS	---	LoggPnt	CAMPBELL	RTMC-PRO	CAMPBELL	MS4	MicroStep-MIS	MS14	MicroStep-MIS	AWSPUS	NEEA	SWMET	AMD TECH	---	---	---	---	---	---	---	---	---	---
ANEMÔMETRO (CABECEIRA PRINCIPAL)	DIREÇÃO DO VENTO	86000	R.M. YOUNG	09002	R.M. YOUNG	91000	R.M. YOUNG	WIND OBSERVER II	MicroStep-MIS	ANESB	NEEA	91500	R.M. YOUNG	91500B	R.M. YOUNG	---	---	---	---	---	---	---	---
	VELOCIDADE DO VENTO																						
SENSOR DE TEMPERATURA	TEMPERATURA	4138LE2	R.M. YOUNG	4138LF2	R.M. YOUNG	4138ZVC	R.M. YOUNG	RHT175	MicroStep-MIS	UTA	NEEA	RHT745	AMD TECH	---	---	---	---	---	---	---	---	---	---
SENSOR DE UMIDADE RELATIVA (UR)	UMIDADE RELATIVA (UR)																						
BARÔMETRO PRINCIPAL	PRESSÃO ATMOSFÉRICA	61302L / 61302V	R.M. YOUNG	MSB780V	MicroStep-MIS	PT8330	Vaisala	BAR-4V	NEEA	DB73	AMD TECH	---	---	---	---	---	---	---	---	---	---	---	---
BARÔMETRO RESERVA	PRESSÃO ATMOSFÉRICA	61302L / 61302V	R.M. YOUNG	PT8330	Vaisala	PA-50	Vaisala	PA-21	Vaisala	PT8220	Vaisala	PA-21	Vaisala	M2236A	ML-2	MSB780V	MicroStep-MIS	7223 / 7223-05A	RUSKA	170	SETRA	DB73K	AMD TECH